



FORM PTO-1449	SERIAL NO. 10/693,425	CASE NO. 4865-133
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	FILING DATE October 24, 2003	GROUP ART UNIT 1755
(use several sheets if necessary)		APPLICANT(S): Nixon et al.

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER <small>Number-Kind Code (if known)</small>	DATE	NAME	CLASS/ SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER <small>Number-Kind Code (if known)</small>	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION YES OR NO
KEG	B1 2000-256064 (translation)	9/19/00	Japan		Yes

EXAMINER INITIAL	OTHER ART – NON PATENT LITERATURE DOCUMENTS <small>(Include name of author, title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.)</small>	
KEG	B2	Vijay Vasant Pujar, <i>Processing and Microstructural Characterization of Reaction-Formed Silicon Carbide (RFSC) and Computer Simulations, X-Ray Diffraction and High Resolution Transmission Electron Microscopy of Stacking Faults in β-SiC</i> , Case Western Reserve University Dissertation, January 1997, pp. 38-51

EXAMINER /Karl Group/	DATE CONSIDERED 05/23/2006
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.